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## **Preliminary design of insertion devices at Hefei Advanced Light Facility**

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Hefei Advance Light Facility (HALF) is a 2.2 GeV diffraction-limited storage ring, which is developed by National Synchrotron Radiation Laboratory in China. It has 20 long straight sections and 20 middle straight sections. All the experimental stations in the first stage will employ undulator as the light source. In this paper, we introduce the preliminary design of insertion devices of HALF, which includes 11 undulators and 2 wigglers. The undulator design is carefully optimized based on the current undulator technology and experiment user demands. The photon flux of these undulators can cover the photon energy from 5 eV to 10 keV with the flux greater than  $10^{14}$  phs/s/0.1% B.W. It can reach an ultra-high brilliance at the soft X-ray wavelength region. Most of the insertion devices are the elliptically polarized undulators and the in-vacuum undulators, therefore the light source of HALF will be characterized by a flexible tunability on polarization state and a broad range of photon energy from VUV to X-ray wavelength region.

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### **Footnotes**

### **I have read and accept the Privacy Policy Statement**

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